### **AMENDMENTS TO THE CLAIMS**

This listing of claims will replace all prior versions and listings of claims in the application:

#### LISTING OF CLAIMS:

- 1. (previously presented): A method for producing a light-emitting device comprising the steps of disposing a transparent electrode, one or more organic layers and a back side electrode on a substrate to provide a light-emitting structure, and disposing sealing parts on said light-emitting structure to isolate said one or more organic layers from external air, wherein said one or more organic layers comprises a light-emitting layer containing a phosphorescent compound, and said light-emitting layer, said back side electrode and said sealing parts are disposed in an inert gas atmosphere where both of a moisture concentration and an oxygen concentration are 100 ppm or less.
- 2. (Original) The method for producing a light-emitting device according to claim 1, wherein said one or more organic layers is isolated from external air after disposing said light-emitting layer until said sealing parts are disposed.
- 3. (Original) The method for producing a light-emitting device according to claim 1, wherein both of said moisture concentration and said oxygen concentration are 50 ppm or less.

- 4. (Original) The method for producing a light-emitting device according to claim 3, wherein both of said moisture concentration and said oxygen concentration are 30 ppm or less.
- 5. (Original) The method for producing a light-emitting device according to claim 1, wherein at least one of said organic layers is formed by a wet film-forming method.
- 6. (currently amended): The method for producing a light-emitting device according to claim 1, wherein said one or more organic layers comprises a hole-injecting layer in contact with said light-emitting layer and said hole-injecting layer <u>is</u> over said transparent electrode.
- 7. (Original) The method for producing a light-emitting device according to claim 6, wherein both of said hole-injecting layer and said light-emitting layer are formed by a wet film-forming method.
- 8. (Original) The method for producing a light-emitting device according to claim 6, wherein said one or more organic layers further comprises an electron-transporting layer between said light-emitting layer and said back side electrode.

- 9. (Original) The method for producing a light-emitting device according to claim 1, wherein a weight ratio of said phosphorescent compound in said light-emitting layer is 0.1 to 70 weight % based on the total weight of said light-emitting layer.
- 10. (Original) The method for producing a light-emitting device according to claim 1, wherein said phosphorescent compound is an *ortho*-metallation complex.
- 11. (Original) The method for producing a light-emitting device according to claim 1, wherein an ultraviolet-hardening resin is used in combination with said sealing parts to isolate said one or more organic layers from external air.

Claims 12-20 (canceled).

21. (new): A method for producing a light-emitting device comprising the steps of:
disposing a transparent electrode, one or more organic layers and a back side electrode on
a substrate to provide a light-emitting structure;

disposing sealing parts on said light-emitting structure to isolate said one or more organic layers from external air,

wherein said one or more organic layers comprise a light-emitting layer containing a phosphorescent compound; and

disposing said light-emitting layer, said back side electrode, and said sealing parts in an inert gas atmosphere where both moisture concentration and oxygen concentration are 100 ppm or less; and

said one or more organic layers is/are isolated from external air after disposing said lightemitting layer until said sealing parts are disposed.

22. (new): A method for producing a light-emitting device comprising the steps of:
disposing a transparent electrode, one or more organic layers and a back side electrode on
a substrate to provide a light-emitting structure;

disposing sealing parts on said light-emitting structure to isolate said one or more organic layers from external air,

wherein said one or more organic layers comprises a light-emitting layer containing a phosphorescent compound;

disposing said light-emitting layer, said back side electrode, and said sealing parts in an inert gas atmosphere where both moisture concentration and oxygen concentration are 30 ppm or less; and

said one or more organic layers is/are isolated from external air after disposing said lightemitting layer until said sealing parts are disposed.

23. (new): A method for producing a light-emitting device comprising the steps of:

disposing a transparent electrode, one or more organic layers and a back side electrode on a substrate to provide a light-emitting structure;

disposing sealing parts on said light-emitting structure to isolate said one or more organic layers from external air,

wherein said one or more organic layers comprises a light-emitting layer containing a phosphorescent compound; and

disposing said light-emitting layer, said back side electrode, and said sealing parts in an inert gas atmosphere where both moisture concentration and oxygen concentration are 30 ppm or less; and

said one or more organic layers is/are isolated from external air after disposing said lightemitting layer until said sealing parts are disposed, and wherein at least one of said organic layers is formed by a wet film-forming method.